WEST Search History



DATE: Wednesday, June 13, 2007

| Hide? | <u>Set</u> <u>Name</u> | Query | <u>Hit</u> Count |
|---|---|--|---------------------|
| $DB=USPT$; $PLUR=YES$; $OP=\dot{A}DJ$ | | | |
| | L7 | 5934566.pn. | 1 |
| | DB=PGPB, USPT; PLUR=YES; OP=ADJ | | |
| Ü | L6 | (clean\$3 or treat\$3 or wash\$3) same(drop\$3 with (imping\$3 or hit\$3 or bombard\$3) with (size or diameter or radius or dimension)) | 19 |
| | $DB=EPAB,JPAB,DWPI;\ PLUR=YES;\ OP=ADJ$ | | |
| | L5 | (semiconductor or wafer or substrate or article or workpiece) same (clean\$3 or treat\$3 or wash\$3) same(drop\$3 with (imping\$3 or hit\$3 or bombard\$3)) same (size or diameter or radius or dimension) | 0 |
| | DB=P | GPB, USPT; PLUR=YES; OP=ADJ | |
| | L4 | (semiconductor or wafer or substrate or article or workpiece) same (clean\$3 or treat\$3 or wash\$3) same(drop\$3 with (imping\$3 or hit\$3 or bombard\$3)) same (size or diameter or radius or dimension) | 11 |
| | DB=EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ | | |
| | L3 | (semiconductor or wafer or substrate or article or workpiece) same (clean\$3 or treat\$3 or wash\$3) same(drop\$3 with (imping\$3 or hit\$3 or bombard\$3)) | 11 |
| | DB=USPT; PLUR=YES; OP=ADJ | | |
| | L2 | L1 | 28 |
| | DB=P | GPB, USPT; PLUR=YES; OP=ADJ | |
| | L1 | (semiconductor or wafer or substrate or article or workpiece) same (clean\$3 or treat\$3 or wash\$3) same(drop\$3 with (imping\$3 or hit\$3 or bombard\$3)) | 44 |

END OF SEARCH HISTORY